## **11/990859** IAPO5Rec'd PCT 22 FEB 2008

U.S. DEPARTMENT OF COMMERCE Form PTO-1595 (Rev. 08/05) 03-04-2008 OMB No. 0651-0027 (exp. 6/30/2008) United States Patent and Trademark Office 103485913 To the Director of the U.S. Patent and cuments or the new address(es) below. 2. Name and address of receiving party(ies) 1. Name of conveying party(ies): Tetsuhiro TANABE ROHM CO., LTD. Internal Address: X No Yes Additional name(s) of conveying party(ies) attached? Street Address: 3. Nature of conveyance/Execution Date(s): 21, Saiin Mizosaki-cho, Ukyo-ku, Execution Date(s): February 1, 2008 x Assignment Merger Change of Name Joint Research Agreement Security Agreement City:\_ Kyoto-shi Government Interest Assignment State: Executive Order 9424, Confirmatory License **JAPAN** Country: Additional name(s) & address(es) Yes X attached? 4. Application or patent number(s): A. Patent Application No.(s) B. Patent No.(s) Title: MONOLITHIC SEMICONDUCTOR LASER Additional numbers attached? Yes 5. Name and address to whom correspondence 6. Total number of applications and concerning document should be mailed: patents involved: Robert H. Berdo, Jr. RABIN & BERDO, PC 7. Total fee (37 CFR 1.21(h) & 3.41) \$ 40.00 Internal Address: Atty. Dkt.: KAW-157NP Authorized to be charged by credit card Street Address: 1101 14th St., NW Authorized to be charged to deposit account Suite 500 **Enclosed** None required (government interest not affecting title) 02/26/2008 GFREY1 00000024 11990859 04 FC:8021 40 Washington City: 8. Payment Information DC 20005 State: Zip: a. Credit Card Last 4 Numbers 4591 Expiration Date 08/09 (202) 371-8976 Phone Number: (202) 408-0924 Fax Number: b. Deposit Account Number firm@rabinberdo.com Authorized User Name Email Address: 9. Signature:

Robert H. Berdo, Jr. - 38,075

Name of Person Signing

PATENT

February 22, 2008

Total number of pages including cover sheet, attachments, and documents:

REEL: 020606 FRAME: 0404

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Attornev	Reference	

ASSIGNMENT OF APPLICATION	FOR UNITED STATES LETTERS PATENT
WHEREAS <u>Tetsuhiro Tanabe</u>	,
hereinafter referred to collectively as the assigno	r, has invented a certain improvement relating to
MONOLITHIC SEMICONDUCTOR	R LASER,
instrument; said application to be filed in the Unit [ ] said application having been filed in on, authorizat Robert H. Berdo, Jr., Phillip G. Avruch, and Aller	n the United States Patent and Trademark Office tion being hereby given to my attorneys, Steven M. Rabin n Wood of RABIN & BERDO, P.C., 1101 14th Street, N.W. ntheses (Application Serial No) the
AND WHEREAS <u>ROHM CO., LTD., 21, S</u>	aiin Mizosaki-cho, Ukyo-ku, Kyoto-shi, Japan
any and all patents which may be granted prolongations thereof;  NOW THIS WITNESSETH, that for and in valuable consideration paid by said assignee to said assignor hereby assigns, sells and transferassigns, the full and exclusive right, title and divisions and continuations thereof, and in and granted therefor, including any and all renewals, assignee's successors and assigns, to have, hold all divisions and continuations thereof, and the sail divisions and continuations thereof, and the sail divisions and advantages in anywise arising frow from any and all such patents when granted, including any and beneficial a manner as the said assigner assignment had not been made.  AND said assignor hereby agrees to perform successors or assigns, any and all acts relating to any and all renewals, reissues and prolongations	s the Commissioner of Patents and Trademarks to issud ad all divisions and continuations thereof,
EXECUTED, this <u>01</u> day of _	
WITNESSES:	ASSIGNOR:
Signature:	Signature: Tetsuhiro Tanabe
Name:	Name:Tetsuhiro Tanabe
Address:	
Signature:	
Name:	
Address:	

RABIN & BERDO, P.C., Washington, D.C.

**RECORDED: 02/22/2008** 

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